Supporting Information

Ionic Liquid Modified SnO₂ Nanocrystals as the Robust Electron

Transporting Layer for Efficient Planar Perovskite Solar Cells

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Fig. S1. TEM images of (a) $n-SnO_2$ nanoparticles, (b) fresh TMAH-modified SnO_2 nanoparticles and (c) TMAH-modified SnO_2 store for 12 hs. (d), (e) and (f) are the corresponding HRTEM images of (a), (b) and (c), respectively.



Fig. S2. Dispersion of SnO_2 nanoparticles at 0 h and 12 h. A without TMAH; B with TMAH modification.



Fig. S3. Raman spectra of soda lime glass substrate (black line), $n-SnO_2$ on soda lime glass (red line), and TMAH-SnO₂ on soda lime glass. The dark dot indicate the Raman shift for soda lime glass. Peak located at about 753 cm⁻¹ is a signal of TMAH.



Fig. S4. Optimization of the ETL deposition process. The (a) annealing temperature, (b) TMAH concentration, and (c) spin-coating speed dependent performance of the PSCs. It can be learned that 1 % concentration of TMAH, 2000 rpm of spin coating rate, and 150 °C of annealing temperature is optimized for efficient devices.



Fig. S5. Optical transmittance of the (a) bare FTO and SnO_2 coated FTO substrates, and (b) bare ITO and SnO_2 coated ITO substrates.



Fig. S6. (a) Mophology and (b) *I-V* curve of a FTO substrate from c-AFM measurement, showing ohm contact between the tip and the FTO electrode.

Table S1. Summary of hall measurements on SnO₂ films

Materials	Sheet resistance	Resistivity	Mobility	Carrier
	$(M\Omega)$	(ohm·cm)	$(cm^2 \cdot v^{-1} \cdot s^{-1})$	concentration (cm ⁻³)
n-SnO ₂	214	1.81×10 ²	3.02	1.14×10^{16}
TMAH-SnO ₂	58	1.20×10 ²	4.16	1.24×10 ¹⁶



Fig. S7. Surface SEM images for perovskite deposited on (a) n-SnO₂, (b) 0.5% TMAH-SnO₂, (c) 1% TMAH-SnO₂, (d) 1.5% TMAH-SnO₂ and (e) 2% TMAH-SnO₂, respectively.



Fig. S8. Stability tests for $n-SnO_2$ based and TMAH-SnO₂ based devices sealed with resin. Devices were stored in desiccator under relative humidity of about 15%.



Fig. S9. *J-V* curve of a flexible TMAH-SnO₂ based device constructed on ITO/PEN substrate, showing an efficiency of about 15.07%.